

## APPLICATION DATA SHEET

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Application Information: Title: AVOIDING FIELD OXIDE GOUGING IN SHALLOW  
 TRENCH ISOLATION (STI) REGIONS  
 Classification: Class: Subclass:  
 Tech Center:  
 Drawing Sheets: 3 Drawing to be Published:  
 Docket No: AF01158  
 Type: Utility  
 Secrecy: None

Representative Information: Kelly K. Kordzik, Reg. No. 36,571  
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**Domestic Priority:**

Application:	Continuity Type:	Parent Application:	Parent Filing Date:
None			

**Foreign Priority Information**

Country:	Application Number:	Filing Date:	Priority Claimed:
None			

Assignee: FASL LLC  
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